



AF /1762
JWW

Attorney Docket no: SEL 308

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yamazaki et al.

Serial No.: 10/098,688

Filed: March 15, 2002

For: Heat Treatment Apparatus And
Heat Treatment Method

Examiner: B. Chen

Art Unit: 1762

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to:
the Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450 on

June 29, 2005

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 6/29/05

Signature

Date

RESPONSE D (AFTER FINAL)

Sir:

Applicants have the following response to the Final Rejection of March 29, 2005.

As Applicants are not amending the claims but instead showing herein why the rejections of the claims are incorrect, it is respectfully requested that this response be entered and considered by the Examiner, and the application allowed.

Applicants appreciate the allowance of Claims 58-73, 77-80, 84-87. Applicants will now address each of the Examiner's remaining rejections in the order in which they appear in the Final Rejection.